LIST OF PUBLICATIONS OF DR. UTPAL GANGOPADHYAY


11. “A novel approach for co-firing optimization in RTP for the fabrication of large area mc-Si solar cell” Kyunghae Kim, Suresh Kumar Dhungel, Utpal Gangopadhyay, Jinsu Yoo, Choi Won Seok and Junsin Yi, Thin Solid Films, 26(2006),Pages228-234


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37. “The study of silicon etching using the high density hollow cathode plasma system”, Jinsu Yoo, Junhoi Lee, U. Gangopadhyay, Kyunghae Kim, and Junsin Yi,
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